## WHAT IS CLAIMED IS:

- A photoreactive resin composition comprising:

   a powdered base metal;
   an organic binder;
   a photosensitive organic component; and
   a polycarboxylic acid-based dispersing agent with a molecular weight of about 1,500 or less.
- 2. A photoreactive resin composition according to Claim 1, wherein the molecular weight of the organic binder is about 10,000 or more.
- 3. A photoreactive resin composition according to Claim 2, wherein the polycarboxylic acid-based dispersing agent content is about 0.05 to 0.8 parts by weight relative to 100 parts by weight of the powdered base metal.
- 4. A photoreactive resin composition according to Claim 3, further comprising a polyvalent alcohol and a thixotropic agent.
- 5. A photoreactive resin composition according to Claim 4, wherein the molecular weight of the organic binder is about 60,000 or less.

- 6. A photoreactive resin composition according to Claim 1, wherein the polycarboxylic acid-based dispersing agent content is about 0.05 to 0.8 parts by weight relative to 100 parts by weight of the powdered base metal.
- 7. A photoreactive resin composition according to Claim 1, further comprising a polyvalent alcohol and a thixotropic agent.
- 8. A photoreactive resin composition according to Claim 1, wherein the molecular weight of the organic binder is about 60,000 or less.
- 9. In a method for making a circuit substrate comprising the step of forming a conductive pattern using a photoreactive resin composition, utilizing a photoreactive composition according to Claim 6.
- 10. In a method for making a circuit substrate comprising the step of forming a conductive pattern using a photoreactive resin composition, utilizing a photoreactive composition according to Claim 4.
- 11. In a method for making a circuit substrate comprising the step of forming a conductive pattern using a photoreactive resin composition, utilizing a photoreactive composition according to Claim 2.

- 12. In a method for making a circuit substrate comprising the step of forming a conductive pattern using a photoreactive resin composition, utilizing a photoreactive composition according to Claim 1.
- 13. A method for making a circuit substrate comprising the steps of: applying a photoreactive resin composition according to Claim 1 onto a support:

exposing and developing the photoreactive resin composition to form a predetermined conductive pattern on the support;

transferring the conductive pattern from the support to a substrate; and firing the conductive pattern.

- 14. A method for making a ceramic multilayer substrate according to Claim 13, wherein the substrate is a ceramic green sheet; and wherein a plurality of ceramic green sheets with the conductive patterns are stacked to form a laminate prior to the firing.
- 15. A method for making a circuit substrate comprising the steps of: applying a photoreactive resin composition according to Claim 4 onto a support:

exposing and developing the photoreactive resin composition to form a predetermined conductive pattern on the support;

transferring the conductive pattern from the support to a substrate; and firing the conductive pattern.

- 16. A method for making a ceramic multilayer substrate according to Claim 15, wherein the substrate is a ceramic green sheet; and wherein a plurality of ceramic green sheets with the conductive patterns are stacked to form a laminate prior to the firing.
- 17. A method for making a circuit substrate comprising the steps of: applying a photoreactive resin composition according to Claim 2 onto a support:

exposing and developing the photoreactive resin composition to form a predetermined conductive pattern on the support;

transferring the conductive pattern from the support to a substrate; and firing the conductive pattern.

- 18. A method for making a ceramic multilayer substrate according to Claim 17, wherein the substrate is a ceramic green sheet; and wherein a plurality of ceramic green sheets with the conductive patterns are stacked to form a laminate prior to the firing.
- 19. A method for making a circuit substrate comprising the steps of: applying a photoreactive resin composition according to Claim 1 onto a support:

exposing and developing the photoreactive resin composition to form a predetermined conductive pattern on the support;

transferring the conductive pattern from the support to a substrate; and firing the conductive pattern.

20. A method for making a ceramic multilayer substrate according to Claim 19, wherein the substrate is a ceramic green sheet; and wherein a plurality of ceramic green sheets with the conductive patterns are stacked to form a laminate prior to the firing.